

応用物理学特論・応用物理学特別講義(集中講義)

東京大学理学系研究科物理学専攻

Lecture Slides (PDF files)

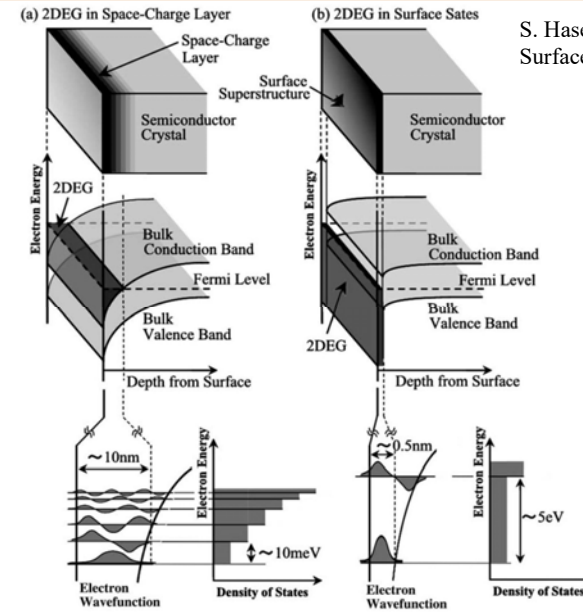
長谷川 修司

<http://www-surface.phys.s.u-tokyo.ac.jp/KougiOHP/>

1. Nanoscience and Surface Physics ナノサイエンスと表面物理  
Nanoscience in Nobel Prize
2. Atomic Arrangements at Surfaces 表面原子配列構造  
Scanning Tunneling Microscopy, Electron Diffraction  
走査トンネル顕微鏡、電子回折
3. Surface Electronic States 表面電子状態  
Surface states 表面状態、Rashba Effect ラッシュバ効果  
Topological Surface States トポロジカル表面状態、  
Band Bending バンド湾曲
- ➡ 4. Surface Electronic Transport 表面電気伝導  
Space-Charge-Layer Transport and Surface-State Transport  
空間電荷層伝導と表面状態伝導  
Atomic-Layer Superconductivity 原子層超伝導

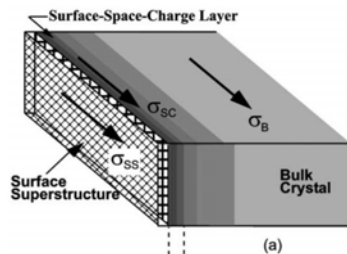
Surface States and Space-Charge Layer (Band bending)

S. Hasegawa & F. Grey,  
Surface Science **500** (2002) 84-104



Three Channels for Electrical Conduction

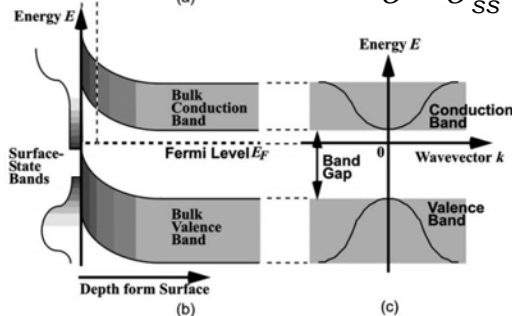
S. Hasegawa & F. Grey,  
Surface Science **500** (2002) 84-104



1. Surface-State Conduction
2. Space-Charge-Layer Conduction
3. Bulk Conduction

Measured conductivity

$$\sigma = \sigma_{ss} + \sigma_{sc} + \sigma_B$$



電界効果トランジスタ Field-Effect Transistor FET

Gate-Control of Band Bending

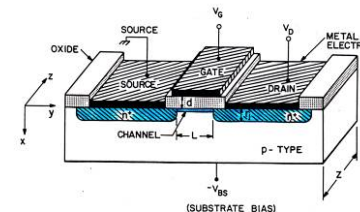
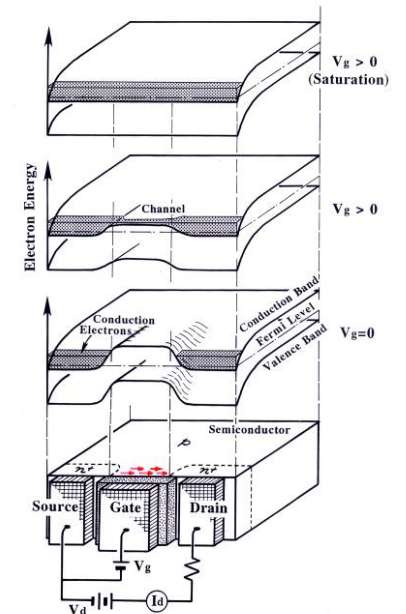


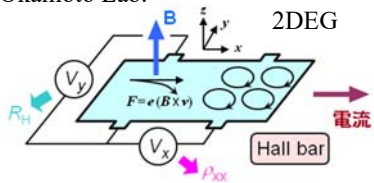
Fig. 3 Schematic diagram of a MOSFET. (After Kahng and Atalla, Ref. 4.)



# 量子ホール効果 Quantum Hall Effect

Nobel prizes  
1985 von Klitzing IQHE  
1998 Laughlin, Storer, Tsui FQHE

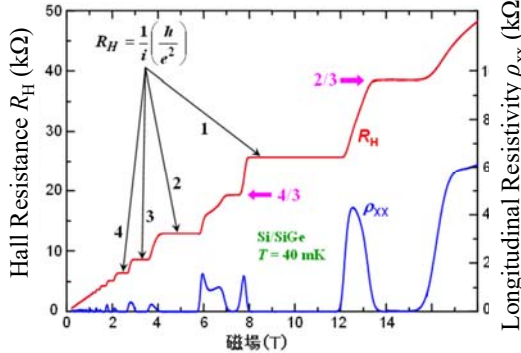
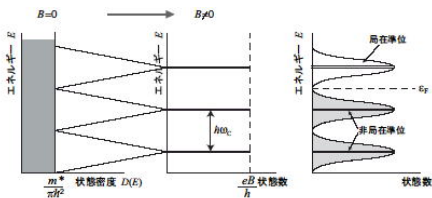
Okamoto Lab.



$$E = \frac{\hbar^2 k^2}{2m^*} \quad \text{Landau levels}$$

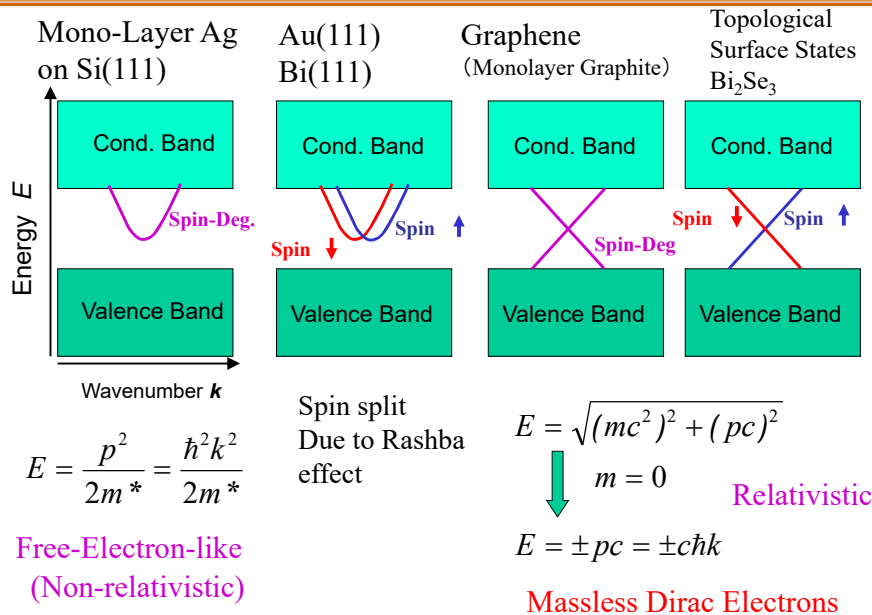
$$E = \hbar \omega_c \left( n + \frac{1}{2} \right) \quad (n = 0, 1, 2, 3, \dots)$$

$$\text{Cyclotron freq. } \omega_c = \frac{eB}{m^*}$$



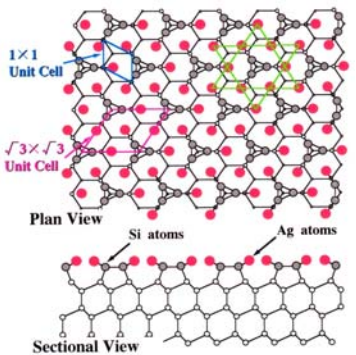
- Hall resistance is quantized. Klitzing constant  $R_K = h/e^2 = 25812.807557(18) \Omega$
- Longitudinal resistance is zero.  $\leftarrow$  edge conduction
- Topology (Berry's phase)

# Various Surface States



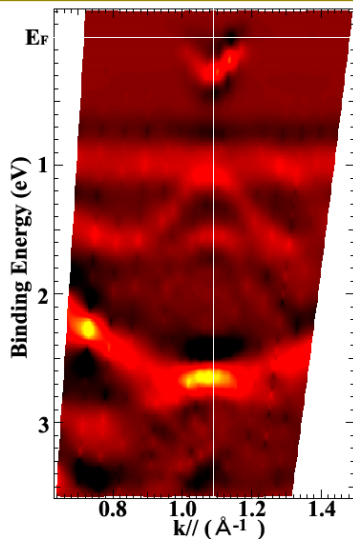
# Mono-Layer Ag on Si : Si (111)-√3 × √3-Ag Surface

2D Metal (Monatomic-Layer Metal)



- Inert and atomically flat surface
- Free-electron-like surface state

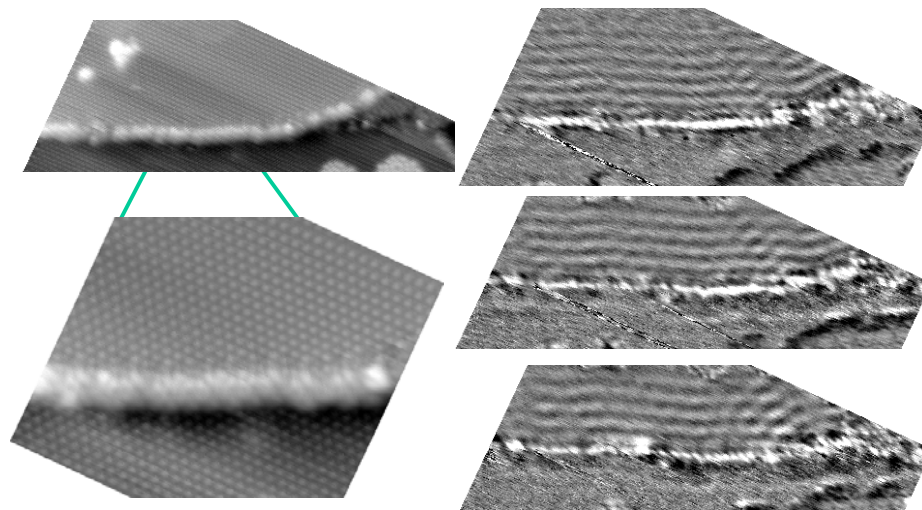
$$E = \frac{p_{//}^2}{2m^*} = \frac{\hbar^2 k_{//}^2}{2m^*}$$



# Standing Waves on Si(111)-√3 × √3-Ag Surface at 65K

STM Images

dI/dV Images



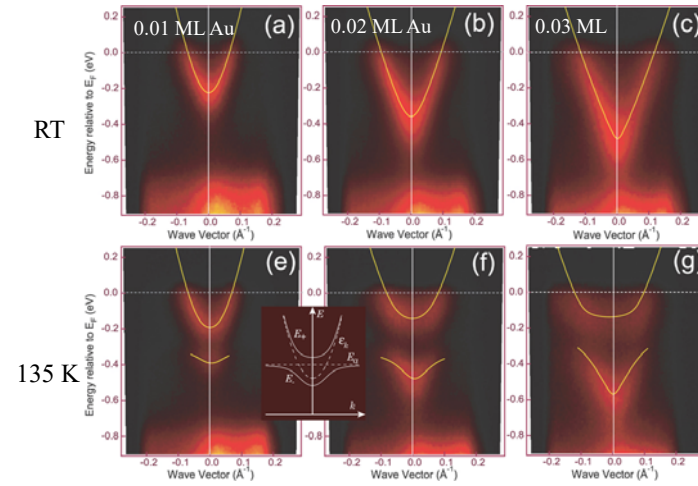
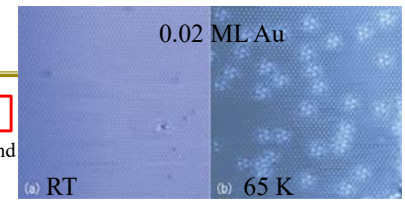
## Carrier Doping Into Surface States to Change Electrical Conductivity

Y. Nakajima, S. Takeda, T. Nagao, S. Hasegawa, and X. Tong:  
**Surface electrical conduction due to carrier doping into a surface-state band on Si(111)- $\sqrt{3}\times\sqrt{3}$ -Ag,**  
 Physical Review B **56** (1997) 6782-6787

M. Aitani, Y. Sakamoto, T. Hirahara, M. Yamada, H. Miyazaki, M. Matsunami, S. Kimura, and S. Hasegawa:  
**Fermi level tuning of topological insulator thin films**  
 Japanese Journal of Applied Physics **52**, 110112 (Oct, 2013)

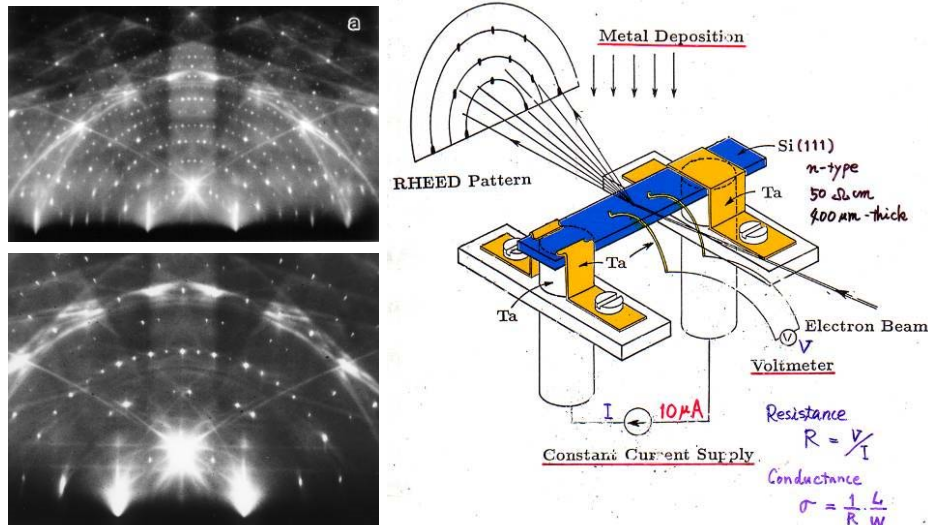
## Au Adsorption on Si(111)- $\sqrt{3}\times\sqrt{3}$ -Ag

- Carrier doping in the surface-state band  
 $\Rightarrow$  Increase in band occupation  $\sigma = e \cdot \mu \cdot n$
- Hybridization of the localized state and surface-state band  
 $\Rightarrow$  Band splitting



C. Liu, I. Matsuda, R. Hobar, and S. Hasegawa, Phys. Rev. Lett. **96**, 036803 (2006).

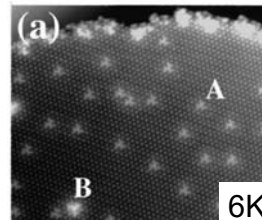
## Macro-Four-Terminal Measurements in UHV



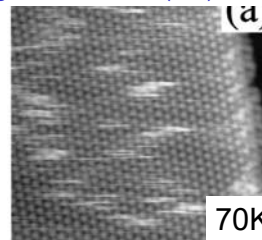
S. Hasegawa, et al., Phys. Rev. Lett. **68**, 1192 (1992)

## Carrier Doping into Surface-State Band by Adatoms

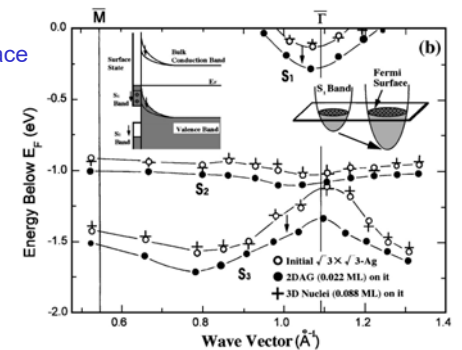
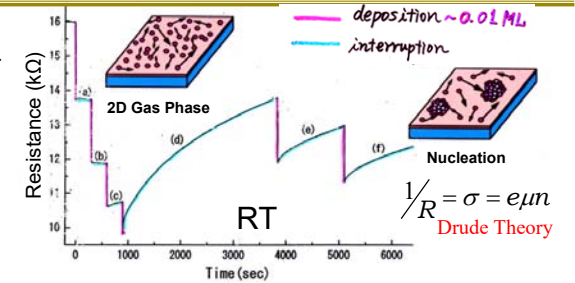
Y. Nakajima, et al.,  
 PRB **54**, 14 134(1996); **56**, 6782 (1997).



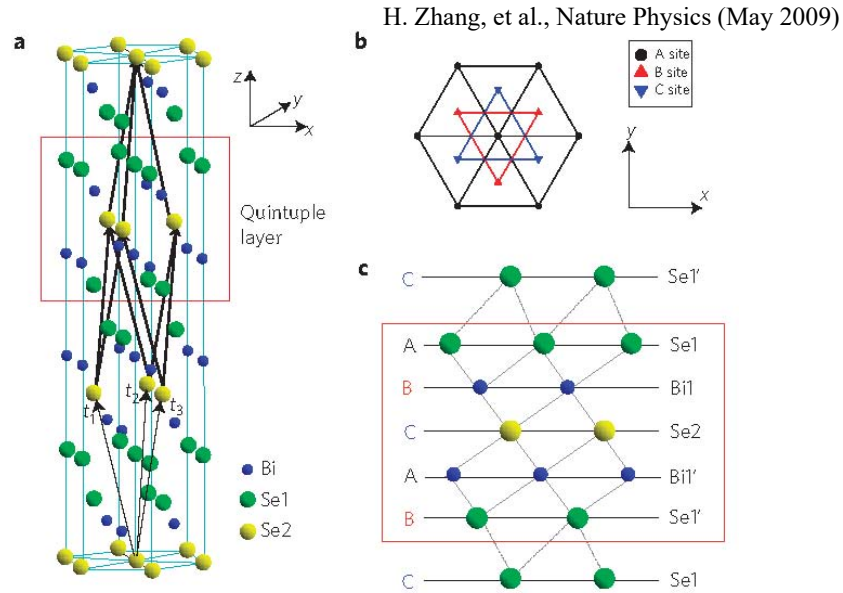
Ag Adatoms on Si(111)- $\sqrt{3}\times\sqrt{3}$ -Ag Surface



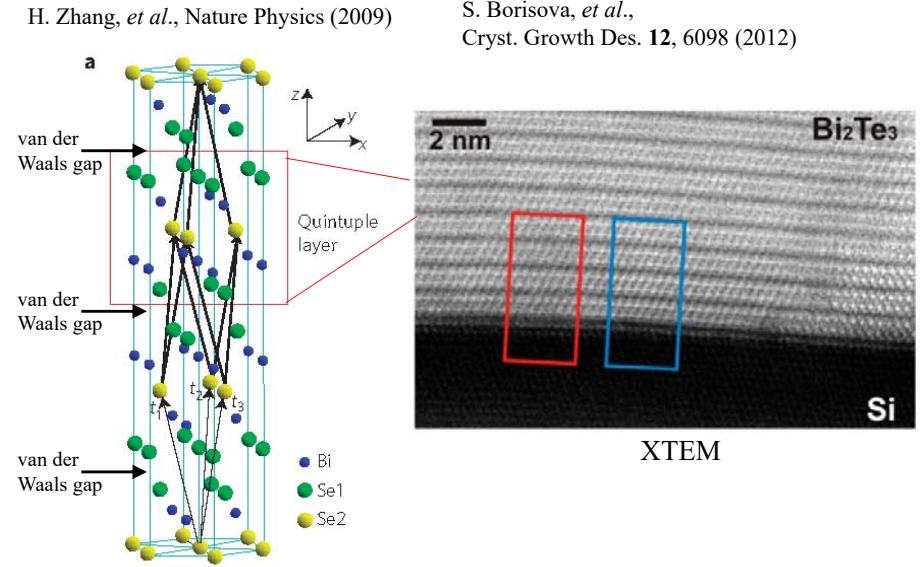
N. Sato, et al., PRB **60**, 16 083(1999).



## Crystal Structure of $\text{Bi}_2\text{Se}_3$ : Topological Insulator

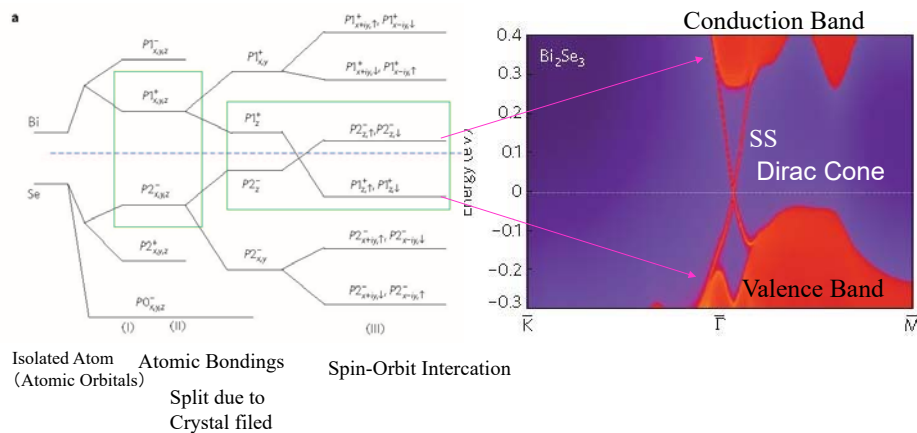


## Crystal Structure of $\text{Bi}_2\text{Se}_3$ ( $\text{Bi}_2\text{Te}_3$ )

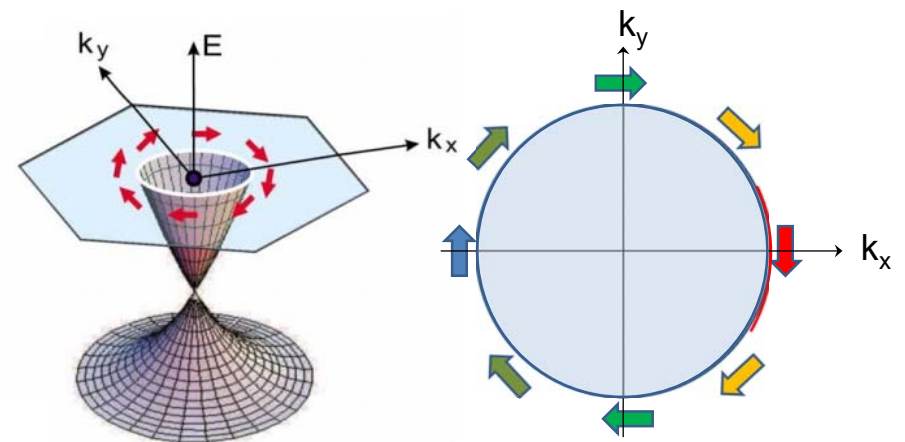


## Electronic States of $\text{Bi}_2\text{Se}_3$ (Theory)

H. Zhang, et al., Nature Physics (May 2009)



## Spin-Textured Fermi Surface + Electric Field $\Rightarrow$ Current - Induced Spin Polarization

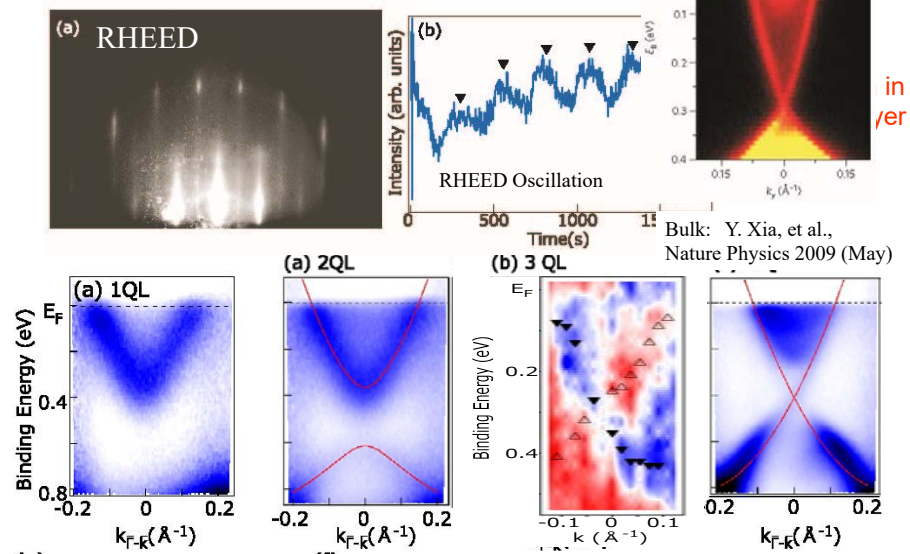


M. Z. Hasan and C. L. Kane, Rev. Mod. Phys. 82, 3045 (2010)

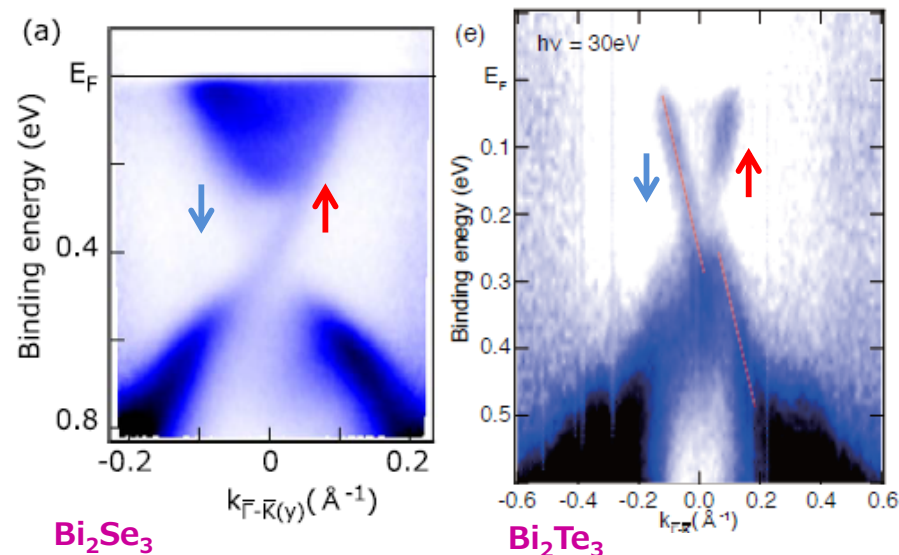
Spin-Textured Fermi Surface  
フェルミ面のスピン繊維構造

# Bi<sub>2</sub>Se<sub>3</sub> : Epitaxial Growth & Bands

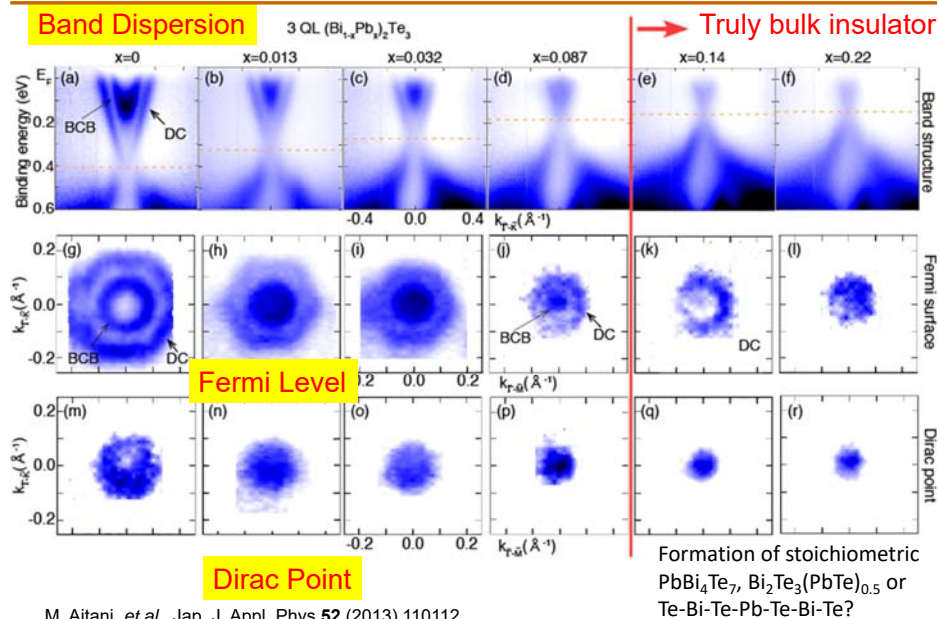
Y. Sakamoto, et al., Phys. Rev. **B81**, 165432 (2010).



# Dirac Cones of Topological Insulators

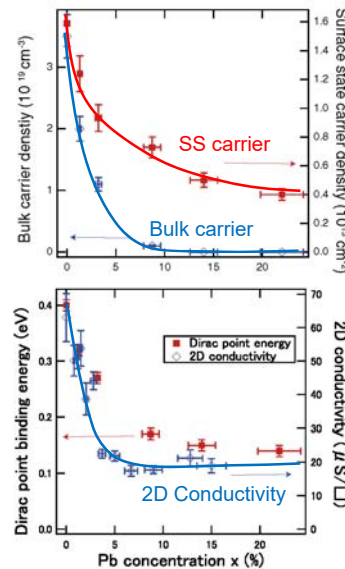


# Hole-doping by Pb alloying in Bi<sub>2</sub>Te<sub>3</sub>



# Conductivity of a single Dirac-cone surface state

M. Aitani, et al., Jpn. J. Appl. Phys. **52**, 110112 (2013)

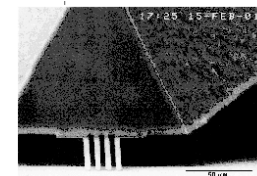


$$\sigma_{SS} \approx 20 \mu\text{S} \approx 0.5 \frac{e^2}{h}$$

Conductivity of Single (Spin-split) Dirac Cone

Drude Model  $\sigma = e\mu n$

Carrier Density  $n = 4 \times 10^{12} \text{ cm}^{-2}$   
 $\Rightarrow$  Mobility  $\mu = 30 \text{ cm}^2/\text{Vs}$



Not high mobility!

M. Aitani, et al., Jap. J. Appl. Phys. **52** (2013) 110112

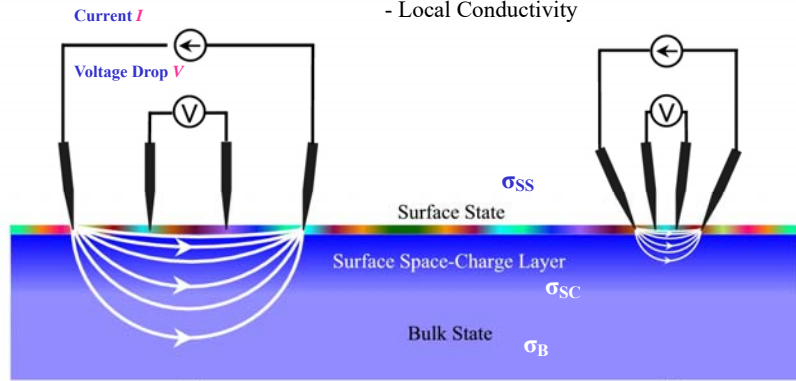
# Four-Point Probe Method for Transport Measurements

Electrical Resistance

$$R = \frac{V}{I} \cdot C$$

C: Correction Factor

- Contact Resistance
- Three Parallel Conduction Channels
- Surface Sensitivity  $\sigma_{meas} = \sigma_{SS} + \sigma_{SC} + \sigma_B$
- Local Conductivity



Macro-4-Point Probe

Bulk-Sensitive  
(Surface -Insensitive)

Micro-4-Point Probe

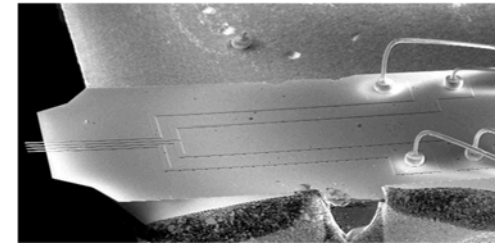
Surface -Sensitive

# Temperature-Variable Monolithic Micro-Four-Point Probe

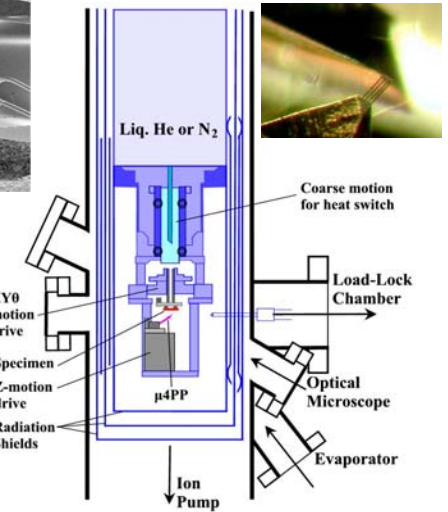
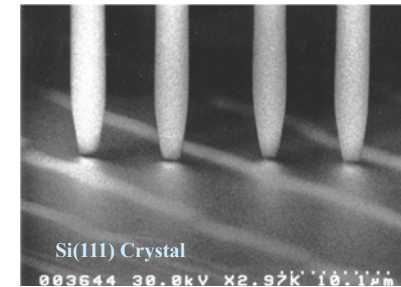
I. Shiraki, et al., Surf. Rev. Lett. 7 (2000) 533.  
C. L. Peteresen, et al., Appl. Phys. Lett. 77 (2000) 3782.  
S. Hasegawa, et al., J. Phys: Cond. Matters 14 (2002) 8379.  
T. Tanikawa, et al., e-J. Surf. Sci. Nanotech. 1 (2003) 50.

Developed at Denmark Technical University

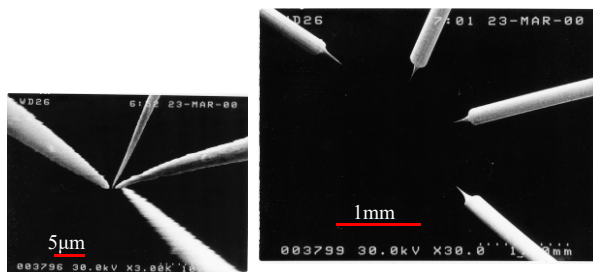
Commercially available;  
<http://www.capres.com>



Contacting to Si(111) sample surface in SEM



# Conductivity Measurements by 4-Tip STM

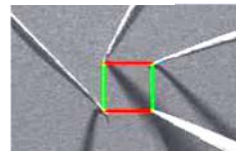


W-Tips

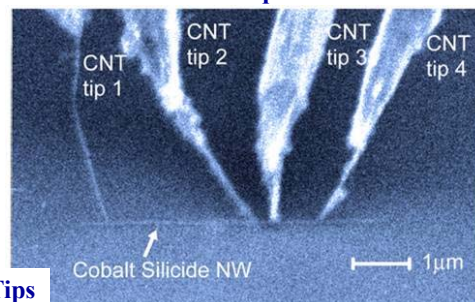
CNT Tips



Linear 4PP

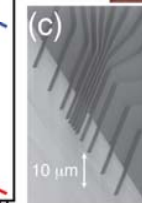
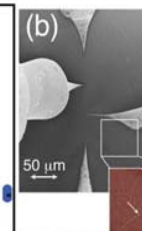
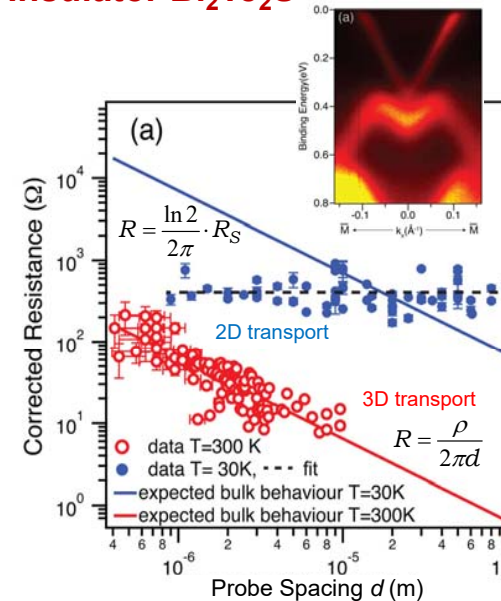


Square 4PP



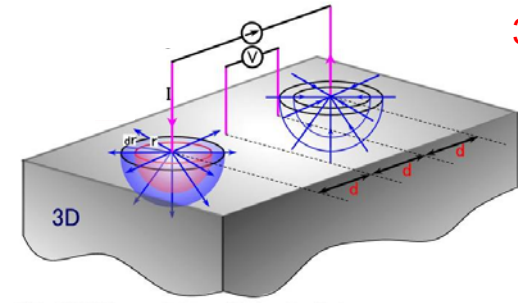
# Surface-Dominated Transport on a Bulk Topological Insulator Bi<sub>2</sub>Te<sub>2</sub>Se

L. Barreto, et al.,  
Nano Letters 14, 3755 (2014)



LT: Bulk carriers  
are frozen out.  
⇒ SS transport only

⇒ Mobility  
 $\mu = 390 \text{ cm}^2/\text{Vs}$   
Fairly high mobility!



3D transport

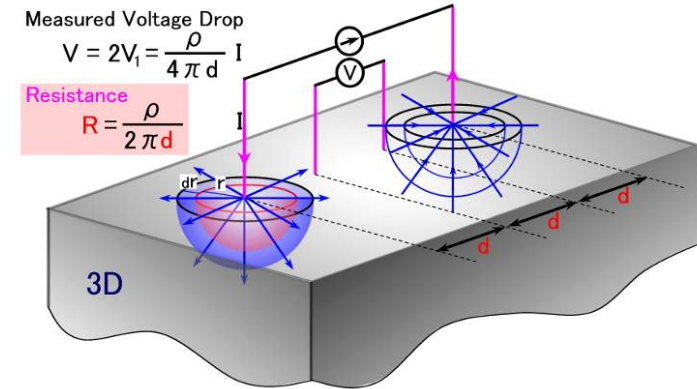
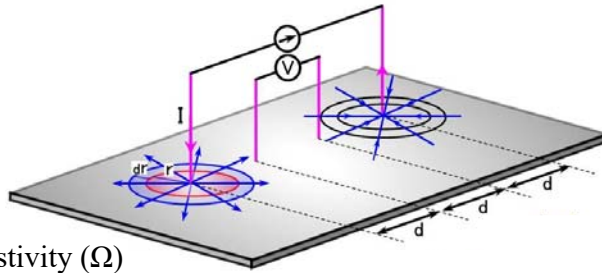
$$R = \frac{V}{I} = \frac{\rho}{2\pi d}$$

$\rho$  : 3D Resistivity ( $\Omega\text{cm}$ )

2D transport

$$R = \frac{V}{I} = \frac{\ln 2}{2\pi} \cdot R_S$$

$R_S$ : Sheet Resistivity ( $\Omega$ )



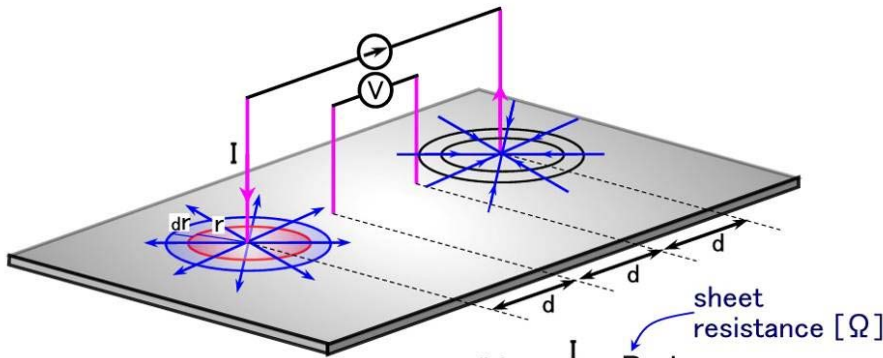
Potential Difference between the two hemispheres

$$dV_1 = \frac{I}{2\pi r^2} \rho dr$$

$\rho$  resistivity [ $\Omega\text{cm}$ ]

Voltage Drop due to Current Injected = Voltage Drop due to Current Flow Out

$$V_1 = \int_d^{2d} \frac{I}{2\pi r^2} \rho dr = \frac{\rho}{4\pi d} I$$



$$V = 2V_1 = \frac{\ln 2}{\pi} R_S I$$

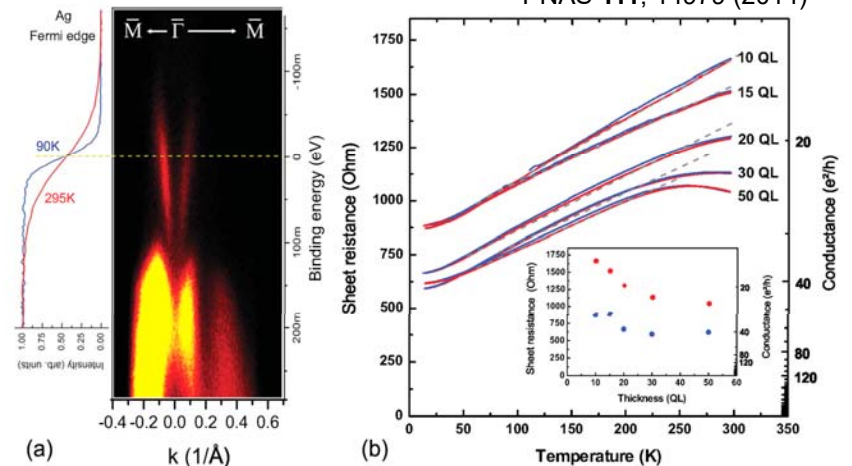
$$R = \frac{\ln 2}{2\pi} R_S : \text{independent of } d$$

$$dV_1 = \frac{I}{2\pi r} R_S dr$$

$$V_1 = \int_d^{2d} \frac{I}{2\pi r} R_S dr = \frac{R_S I}{2\pi} \cdot \ln \frac{2d}{d} = \frac{\ln 2}{2\pi} R_S I$$

Intrinsic conduction through topological surface states of insulating  $\text{Bi}_2\text{Te}_3$  epitaxial thin films on  $\text{BaF}_2$  (111)

K. Hoefler, et al., PNAS 111, 14979 (2014)

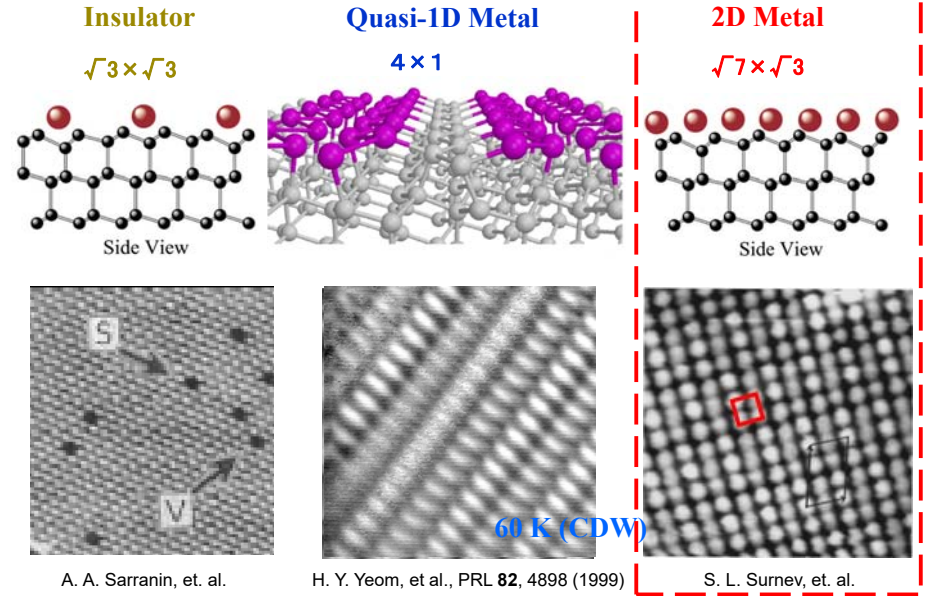


$\Rightarrow$  Mobility  $\mu = 4,600 \text{ cm}^2/\text{Vs}$  Very high mobility!

# Surface-State Superconductivity

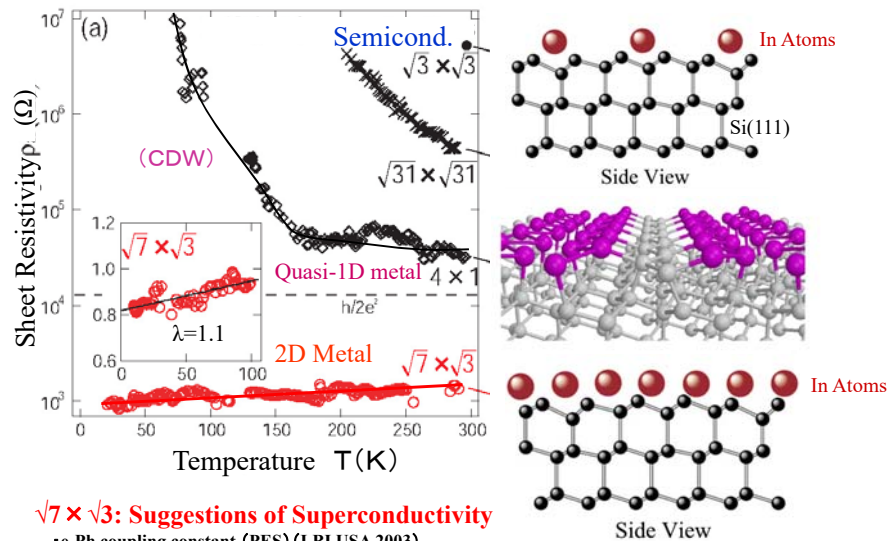
M. Yamada, T. Hirahara, and S. Hasegawa:  
Magnetotransport measurements of  
a superconducting surface state of In- and  
Pb-induced structures on Si(111)  
Phys. Rev. Lett. **110**, 237001 (Jun, 2013).

## Indium-adsorbed Silicon (111) Surface



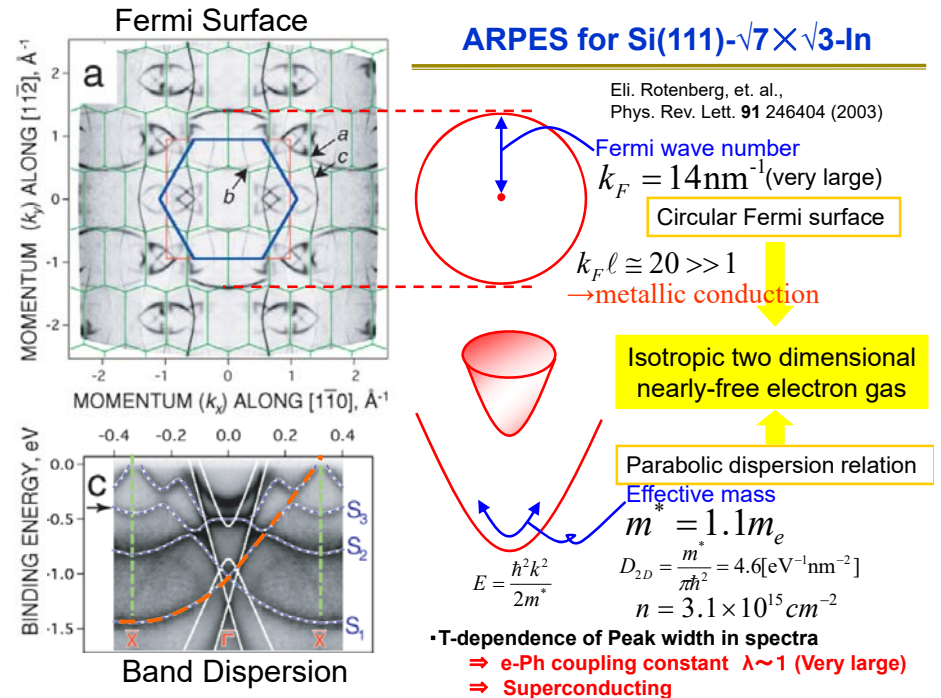
## Electrical Resistance of (Sub)Monolayer In-adsorbed Si

S. Yamazaki, et. al., Phys. Rev. Lett., **106**, 116802 (2011).



$\sqrt{7} \times \sqrt{3}$ : Suggestions of Superconductivity

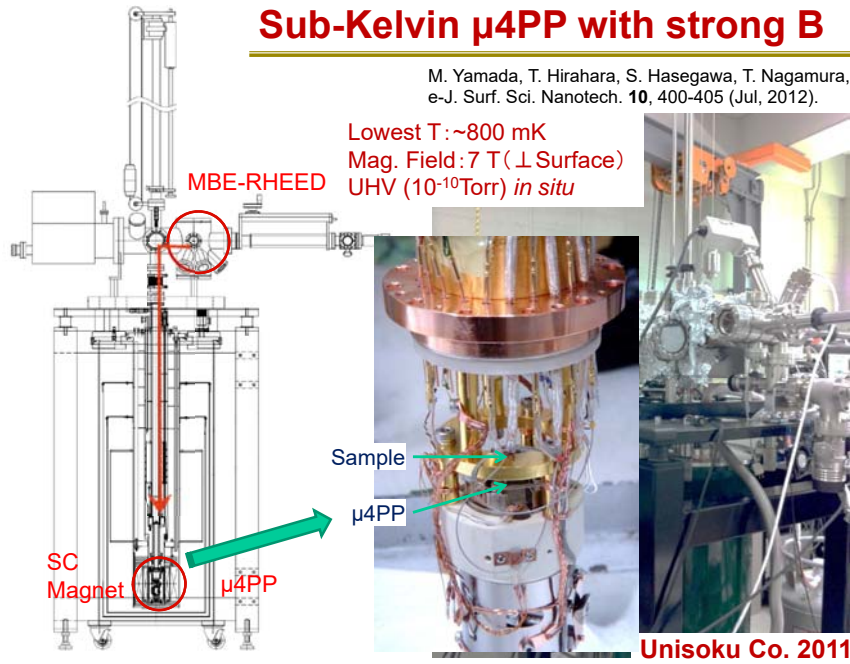
- e-Ph coupling constant (PES) (LBI USA 2003)
- Energy gap (STS) (Tsinghua Univ. China 2010)



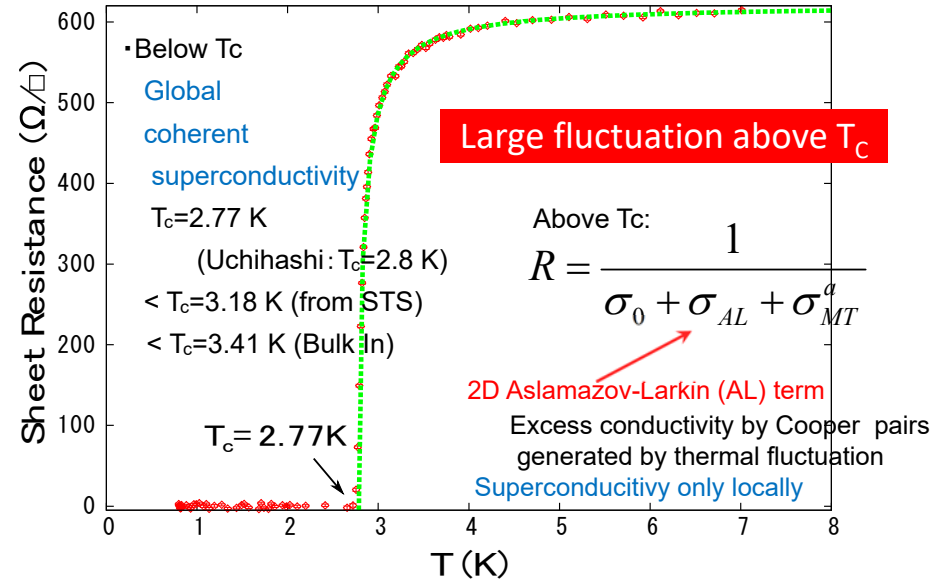


## Sub-Kelvin $\mu$ 4PP with strong B

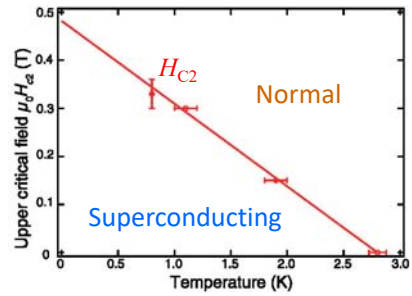
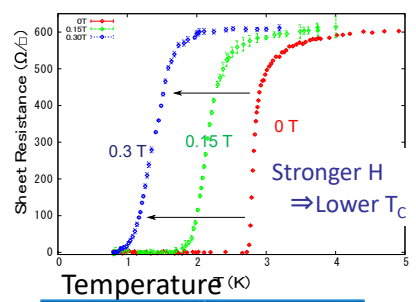
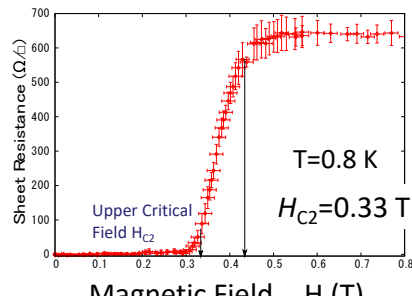
M. Yamada, T. Hirahara, S. Hasegawa, T. Nagamura,  
e-J. Surf. Sci. Nanotech. **10**, 400-405 (Jul, 2012).



## Superconductivity at Si(111) - $\sqrt{7} \times \sqrt{3}$ -In



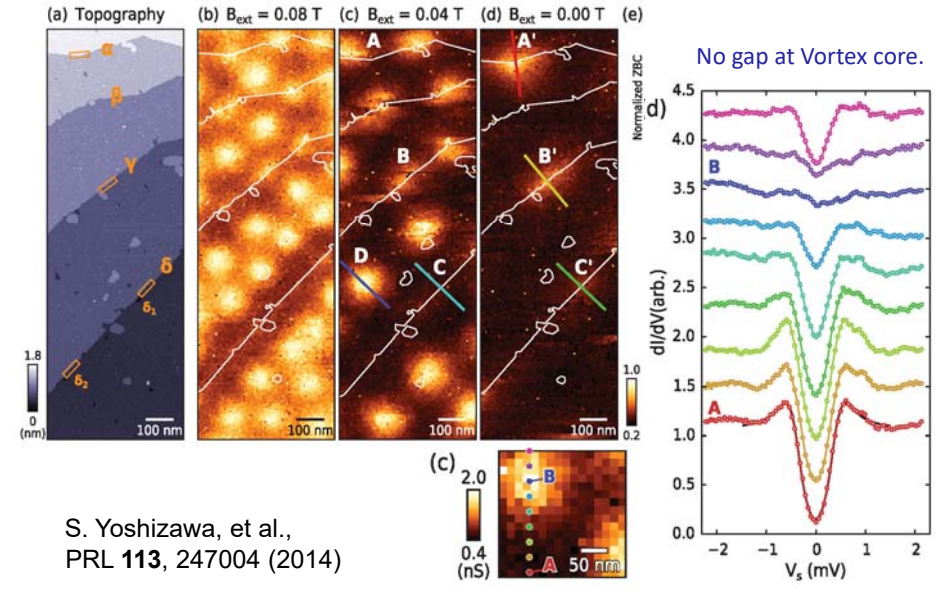
## Si(111)- $\sqrt{7} \times \sqrt{3}$ -In : Under Magnetic Field



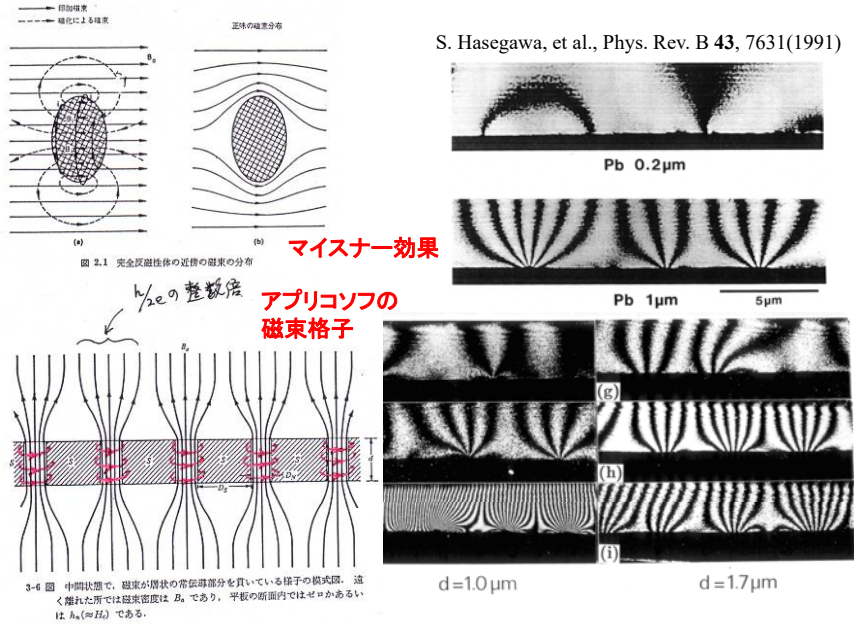
$$H_{c2}(T) = \frac{\phi_0}{2\pi\mu_0\xi(T)^2} = \frac{h}{2e\mu_0\xi(0)^2} \left(1 - \frac{T}{T_c}\right)$$

Very high  $H_c$  (=short  $\xi$ )  
**Strong Critical Field**  $H_{c2}(0) \sim 5000$  Oe  
 cf. bulk In :  $H_c = 293$  Oe  
**Short Coherence Length**  
 $\xi_{GL}(0) \sim 25$  nm  $\ll$  330 nm (Bulk In)

## Vortex and Scanning Tunneling Spectra of Si(111)- $\sqrt{7} \times \sqrt{3}$ -In Double Layer Superconductor

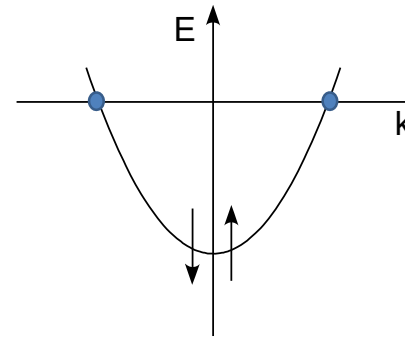


## 超伝導薄膜を貫く磁束量子 —電子ホログラフィによる磁束量子の観察—



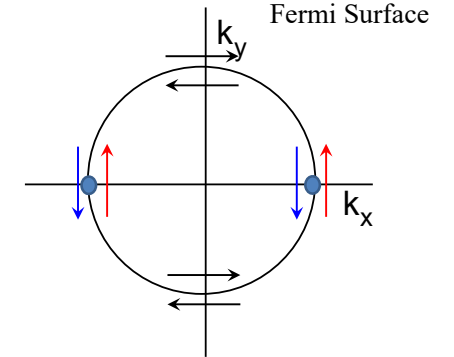
## Cooper Pairs in Free-Electron Band

Band Dispersion



$$E = \frac{\hbar^2}{2m} k^2$$

Fermi Surface

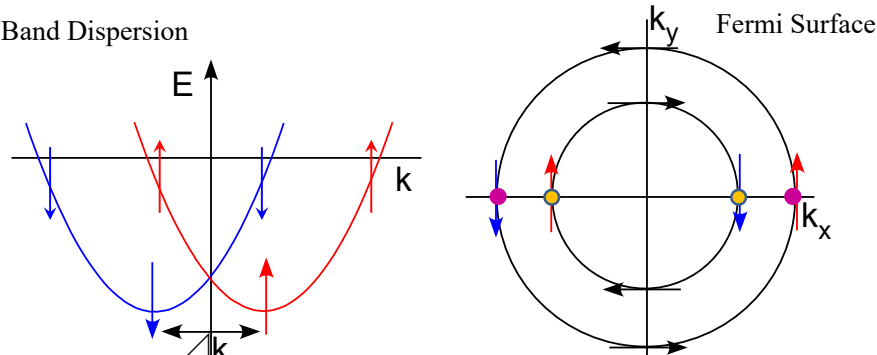


Singlet  $|k \uparrow\rangle | -k \downarrow\rangle - |k \downarrow\rangle | -k \uparrow\rangle$

Triplet  $|k \uparrow\rangle | -k \uparrow\rangle, |k \downarrow\rangle | -k \downarrow\rangle, |k \uparrow\rangle | -k \downarrow\rangle + |k \downarrow\rangle | -k \uparrow\rangle$

## Spin Split and Cooper Pairs in Free-Electron Band

Band Dispersion



⇒ Parity-Broken Superconductors

$$|k \uparrow\rangle | -k \downarrow\rangle = \frac{1}{2} (|k \uparrow\rangle | -k \downarrow\rangle - |k \downarrow\rangle | -k \uparrow\rangle) + \frac{1}{2} (|k \uparrow\rangle | -k \downarrow\rangle + |k \downarrow\rangle | -k \uparrow\rangle)$$

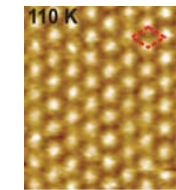
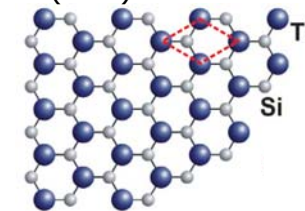
● Outer  $|k \uparrow\rangle | -k \downarrow\rangle$

Singlet (s-wave) Triplet (p-wave)

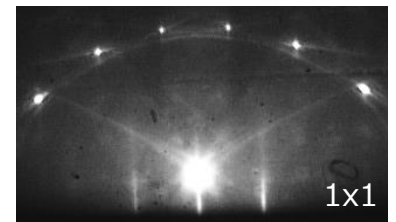
## Sample: Si(111)- $\sqrt{3} \times \sqrt{3}$ -(TI, Pb) Surface Superstructure

D. V. Grunev, et al.; Sci. Rep. 4, 4742 (2014).

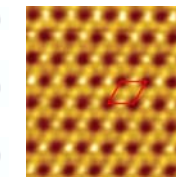
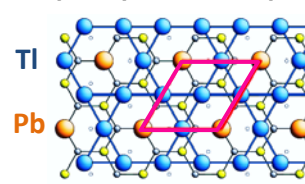
Si(111)-1x1-TI



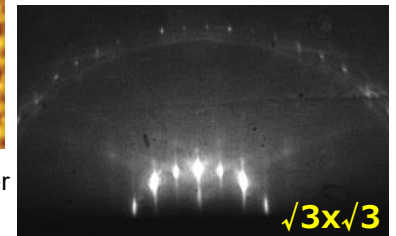
TI 1ML on 7x7 @ 600K



Si(111)- $\sqrt{3} \times \sqrt{3}$ -(TI, Pb)



+Pb 1/3 ML @ 300K



← Mono-Layer

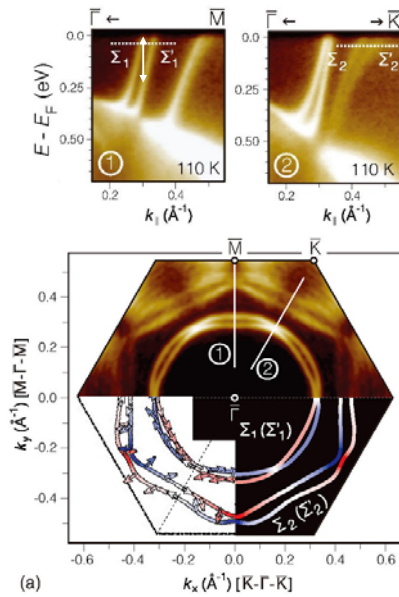
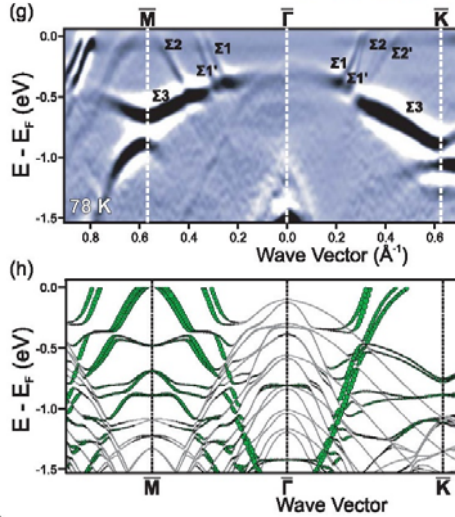
$\sqrt{3} \times \sqrt{3}$

# Si(111)- $\sqrt{3} \times \sqrt{3}$ -(Tl, Pb) :Rashba-type SS

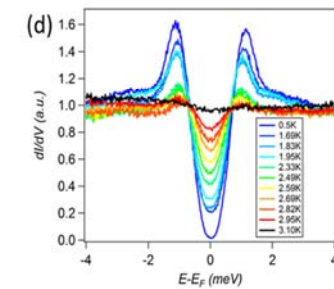
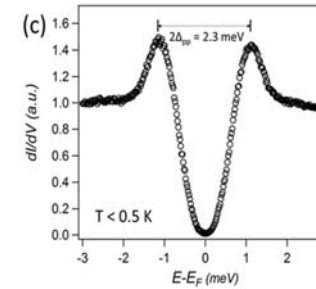
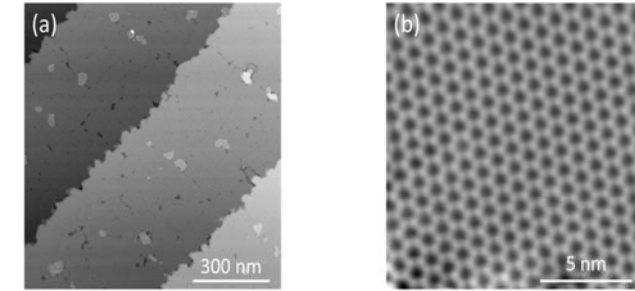
D. V. Gruznev, et al., Sci. Rep. 4, 4742

(2014)  
AKPES+theory

⇒ Spin-Split Surface-State Bands



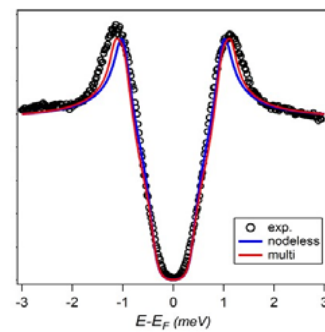
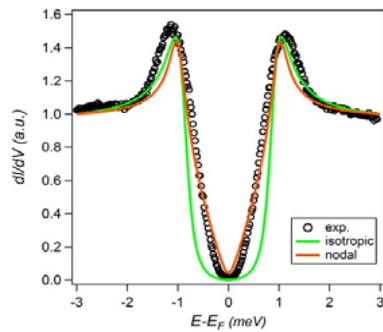
# STS below $T_C$ on Si(111)- $\sqrt{3} \times \sqrt{3}$ -(Tl,Pb) w/o B



# Fitting STS Spectra by Theory

Dynes formula : BCS density of states with broadening parameter ( $\Gamma$ )

$$\frac{dI_{\text{ns}}}{dV} = \rho_i(0)\rho_n(0) \int_{-\infty}^{\infty} \text{Re} \left\{ \frac{|E - i\Gamma|}{\sqrt{((E - i\Gamma)^2 - \Delta^2)}} \right\} \left[ \frac{\exp[(E + eV)/k_B T]}{k_B T [1 + \exp[(E + eV)/k_B T]]^2} \right] dE$$



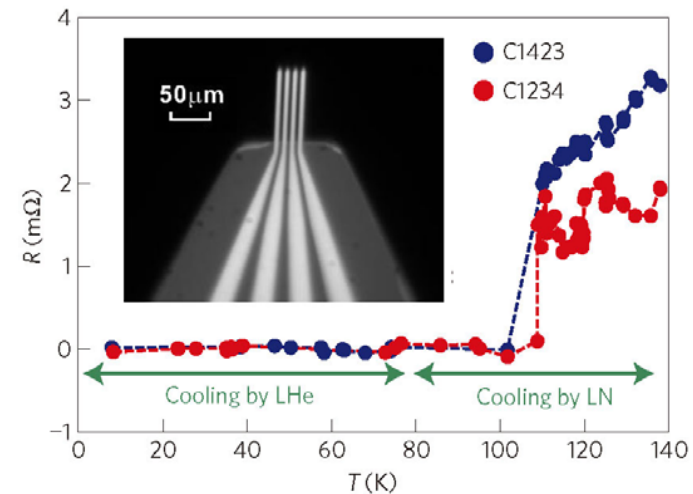
**s-wave (isotropic gap)**  
 $\Delta = \text{const. (1.0 meV)}$

**anisotropic gap**  
 $\Delta = \Delta_0 + \Delta_1 \cos \theta$   
 $\Delta_0 = 0.47 \text{ meV}$   
 $\Delta_1 = 0.84 \text{ meV}$

# Superconductivity above 100 K in single-layer FeSe films on doped SrTiO<sub>3</sub>

J-F. Ge, et al.,  
Nat. Mat. (Nov, 2014)

measured in situ by  $\mu$ 4PP in UHV



Cf: Bulk FeSe  
 $T_C = 9.4 \text{ K}$

# Spin Transport at Surfaces

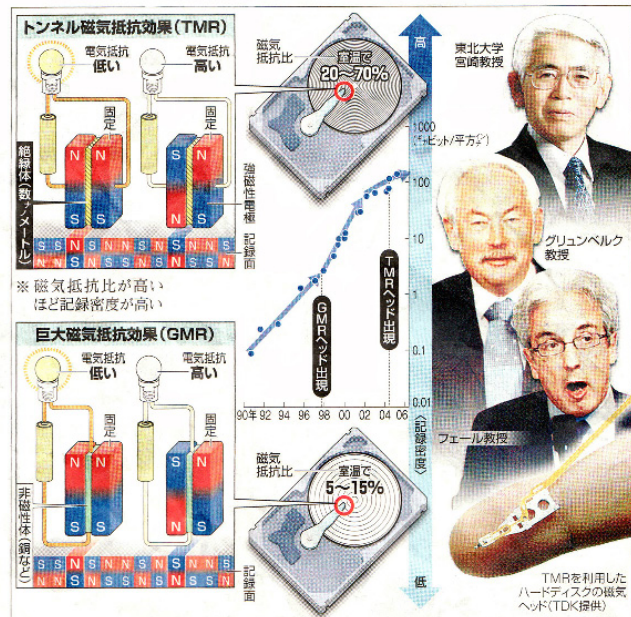
T. Tono, T. Hirahara, and S. Hasegawa:  
 In situ transport measurements on ultrathin Bi(111) films using a magnetic tip: Possible detection of current-induced spin polarization in the surface states  
 New J. Phys. **15**, 105018 (Oct 2013)

# Utilizing Spins

- Storage Media  
 記憶媒体      Magnetic Disk/Head, MRAM, ...
- Energy-Saving /High-Speed Devices  
 省エネ・高速素子  
 spin current  
 spin transistors  
 sensors
- 量子情報処理素子  
 Quantum Information Devices  
 Superposition of spin-up and spin-down states

Magnetic Materials  
 Hetero-, Wire-structures  
 Diluted Mag. Semiconductors  
 Magnetic molecules  
 Graphene  
 Topological Insulators

2007年(平成19年)10月29日



Miyazaki  
(Tohoku Univ.)

Gruenberg  
(Germany)

Fert  
(France)

## The Nobel Prize in Physics 2007



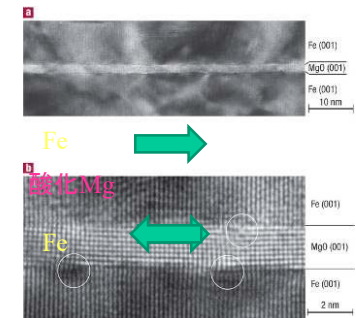
### Discovery of Giant MagnetoResistance (GMR) Effect

巨大磁気抵抗効果の発見 → 磁気ヘッド (ハードディスクの小型化・高密度化)  
 Magnetic Head (HDs becomes smaller and high-density)



Albert Fert  
 France  
 南パリ大学  
 b. 1938

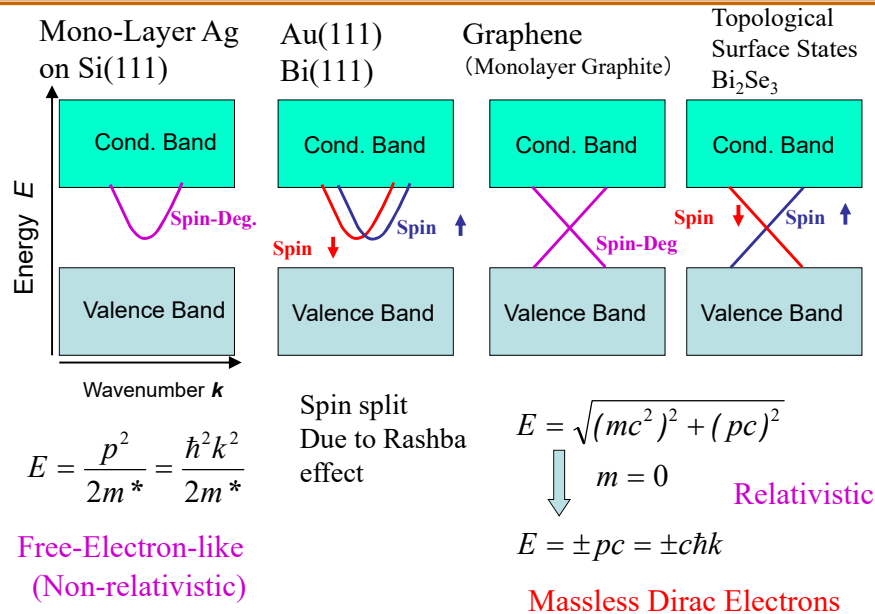
Peter Grünberg  
 Germany  
 Julich Inst  
 b. 1939



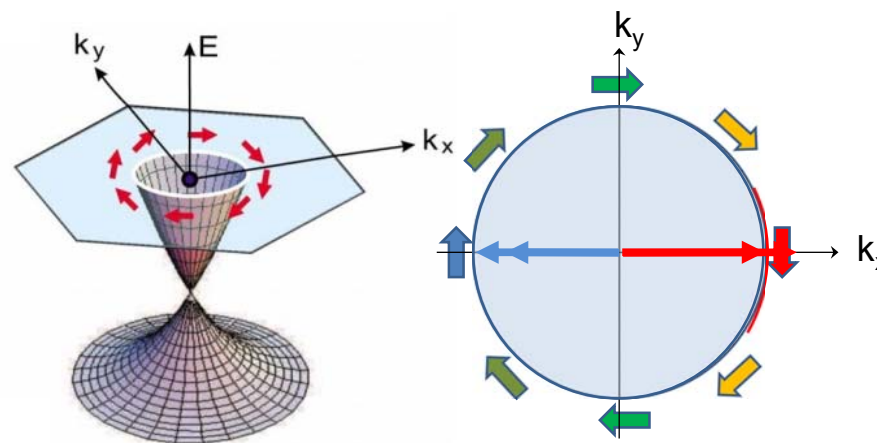
S. Yuasa, et al., Nature Materials 3, 868 (2004).

### Tunnel MagnetoResistance (TMR) Effect

## Various Surface States



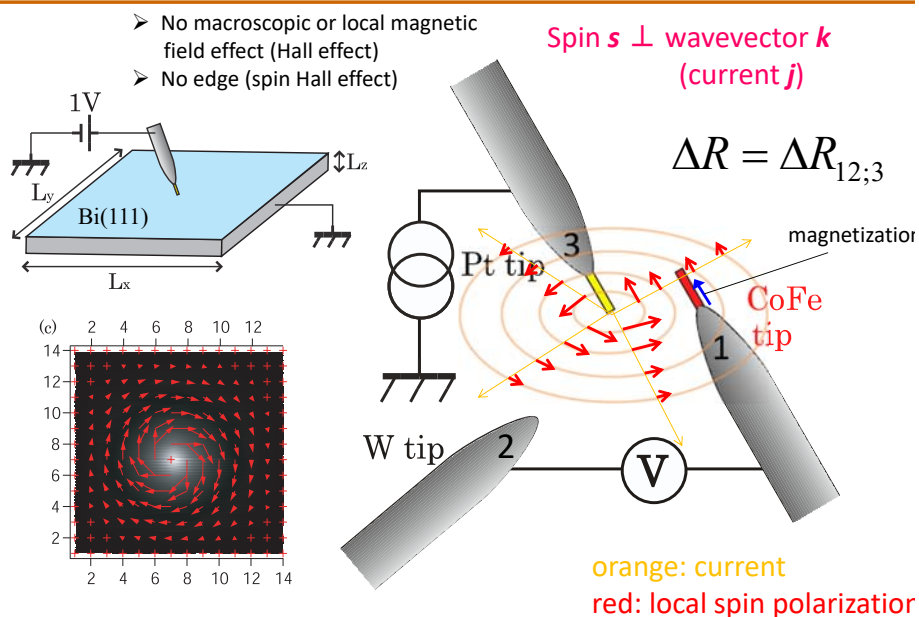
## Spin-Textured Fermi Surface + Electric Field ⇒ Current-Induced Spin Polarization 電流誘起スピン偏極



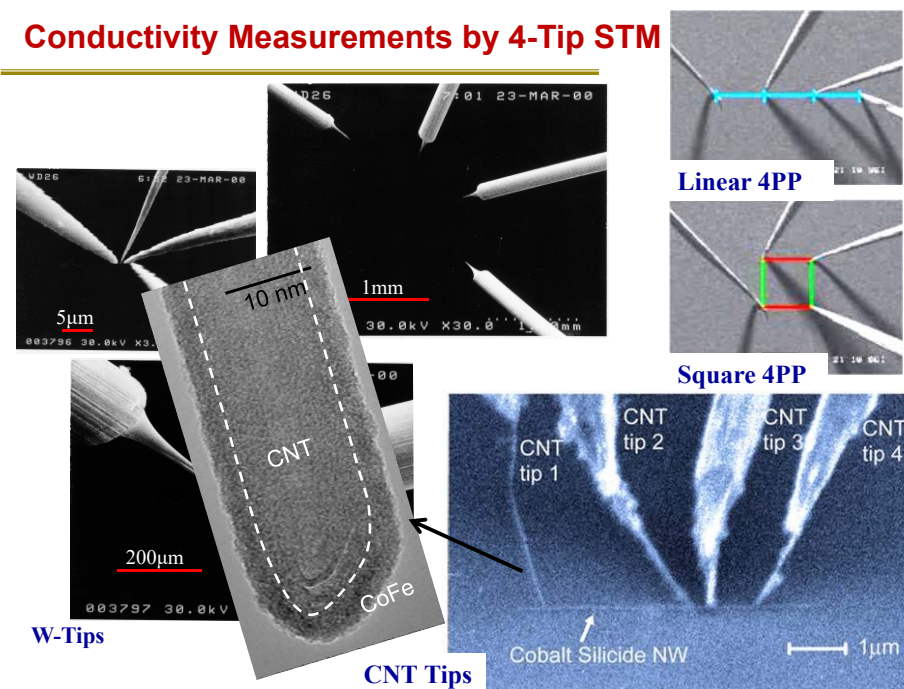
M. Z. Hasan and C. L. Kane, Rev. Mod. Phys. **82**, 3045 (2010)

Spin-Textured Fermi Surface  
フェルミ面のスピン繊維構造

## Current-induced Spin Polarization



## Conductivity Measurements by 4-Tip STM



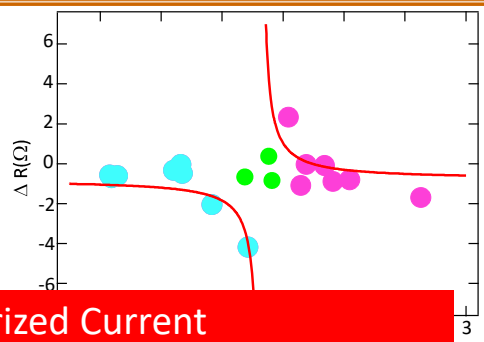
# Signal of Spin Orientation on Bi(111) Surface

$$\vec{s} = -\frac{\hbar}{2} \tanh\left(\frac{\alpha_R \partial \mathbf{k}}{k_B T}\right) \hat{\theta}$$

$$\partial \mathbf{k} = \frac{e\tau}{\hbar} \vec{E}$$

$$\vec{s} \approx -\frac{\hbar \alpha_R e \tau}{2 k_B T} E \hat{\theta}$$

$$\vec{E} = \frac{I}{\sigma d}$$

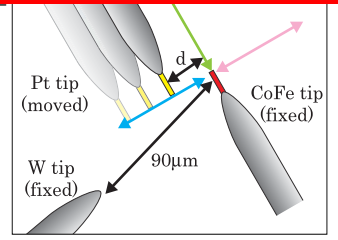


Detecting Spin-Polarized Current on a Non-magnetic Surface ?

$$\Delta R = \eta \frac{AN_\sigma k_B T \hbar 2\pi\sigma d}{2eI} \sim \eta \frac{2eI}{2eI}$$

$$\text{Spin Density } s_D \approx N_0 e \frac{\mu_\uparrow - \mu_\downarrow}{2}$$

$d$	10 nm	100 nm	1 μm
$\mu_\uparrow - \mu_\downarrow$	300 μV	30 μV	3 μV
$s_D$	800 μm <sup>-2</sup>	80 μm <sup>-2</sup>	8 μm <sup>-2</sup>



# Spin Hall Effect

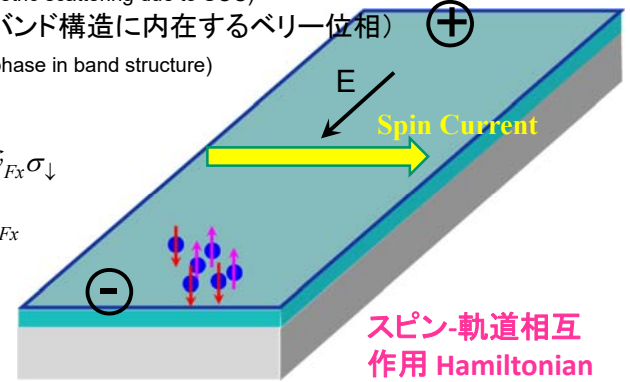
磁場の印加が不要  
No external magnetic field  
非磁性物質 (SOCが強い)  
Non-magnetic materials (strong SOC)

- 外因性 (SOCによる非対称散乱)  
Extrinsic reason (asymmetric scattering due to SOC)
- 内因性 Intrinsic (バンド構造に内在するベリー位相)  
Intrinsic reason (Berry phase in band structure)

Spin Current

$$J_S = n_\uparrow \vec{v}_{Fx} \sigma_\uparrow - n_\downarrow \vec{v}_{Fx} \sigma_\downarrow$$

$$\dots = \frac{n}{2} (\sigma_\uparrow - \sigma_\downarrow) \cdot \vec{v}_{Fx}$$

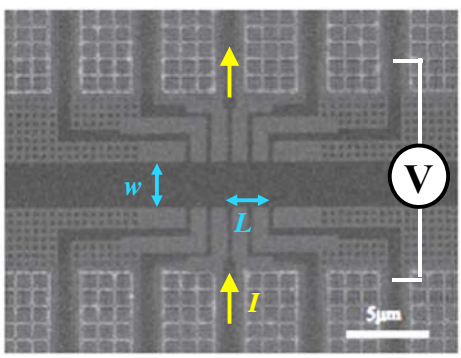
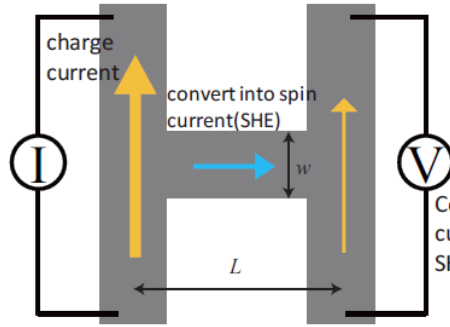


スピン-軌道相互作用 Hamiltonian

$$H = \frac{1}{2m} p^2 + V(x) + \frac{1}{4mc^2} \sigma \cdot (\text{grad } V \times p)$$

# Detecting Spin Hall Effect

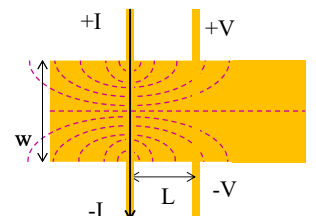
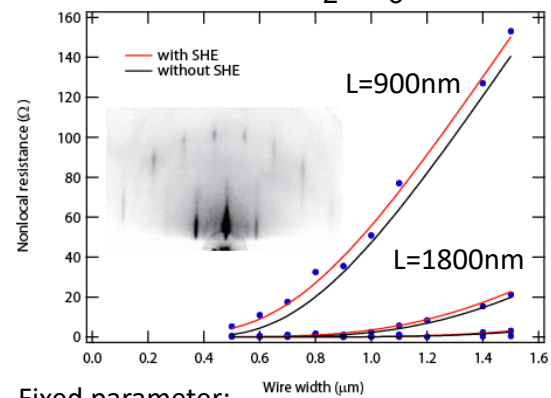
- Bi<sub>2</sub>Se<sub>3</sub>; 8QL thick
- Se capping → FIB Fabrication
- Heating → Remove Se Capping



Current → SHE → Spin Flow → ISHE → Current/Voltage → Electrical Detection

It should be  $L < L_s$  (Spin relaxation length).

# Results on Bi<sub>2</sub>Se<sub>3</sub> thin film (8QL) at RT



Fixed parameter:

$$\rho_{2D} = 805 \Omega$$

fitting parameter

$$\text{Spin-Hall Angle } \gamma = \sigma_s / \sigma_c = 0.032 \pm 0.005$$

$$\text{Spin Diffusion Length } l_s = 0.23 \pm 0.09 \mu\text{m}$$

From Ohm's law  $R_c = \frac{2\rho_{2D}}{\pi} \log \coth\left(\frac{\pi L}{2w}\right)$

From SHE

$$R_{nl}(x) = \frac{1}{\pi} \left(\frac{\beta_s}{\sigma}\right)^2 \frac{1}{\sigma} \int_0^\infty \cos\left(\frac{x}{l_s} k\right) \left(1 - \exp\left(-\frac{w}{l_s} \sqrt{k^2 + 1}\right)\right) \tanh\left(\frac{k w}{2 l_s}\right) \frac{k dk}{k^2 + 1}$$